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FEB 04 2002
TC 1700

INFORMATION DISCLOSURE STATEMENT BY APPLICANT		Complete if Known	
	Application Number	09/913,986	
	Filing Date	August 16, 2001	
	First Named Inventor	Peter Dress, et al	
	Group Art Unit	Not Known	
	Examiner Name	Not Known	
	Attorney Docket No.	AZ 2796	

FOREIGN PATENT DOCUMENTS							
Examiner Initials	Cite No.	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation
MM	1	EP0711108B1	26 Aug 1993	Europe			Yes <input checked="" type="checkbox"/> No <input type="checkbox"/>
	2	DE19545573A1	12 Jun 1997	Germany			X
	3	DE9218974U1	02 Oct 1996	Germany			X
	5	DE4024642C2	06 Feb 1992	Germany			X

OTHER PRIOR ART & NON PATENT LITERATURE DOCUMENTS		
Examiner Initials	Cite No.	Citation
W	6	Patent Abstract of Japan, No. 04146615 dated 20 May 1992
	8	Patent Abstract of Japan, No. 56070634 dated 12 June 1981
	9	Patent Abstract of Japan, No. 05084460 dated 06 April 1993
↓	10	IBM "Upside-Down Resist Coating of Semiconductor Wafers" Technical Disclosure Bulletin, Vol. 32, No. 1 dated June 1989

Examiner	KARLA MOORE	Date	8/10/02
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10/18/2001